



PATENT APPLICATION  
Docket No.: 4591-357  
Client Ref. No. IC12241-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Hong-Soo KIM, et al.

Serial No.: 10/726,788 Examiner: Wilson, Christian D.

Filed: December 2, 2003 Group Art Unit: 2891

Confirmation No.: 6111

For: METHODS OF FORMING SEMICONDUCTOR DEVICES  
HAVING FIELD OXIDES IN TRENCHES AND DEVICES  
FORMED THEREBY

Mail Stop Issue Fee  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE UNDER 37 CFR § 312

Responsive to the Notice of Allowance, dated July 28, 2005, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.

ok to enter  
CDW 11/1/05